

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/510,389 Confirmation No. : 6492
First Named Inventor : Nobuo ISHII
Filed : December 14, 2004
TC/A.U. : 1792
Examiner : DHINGRA, RAKESH KUMAR

Docket No. : 101248.55500US
Customer No. : 23911

Title : Plasma Processing System

REPLY

Mail Stop AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The following amendments and remarks are respectfully submitted in response to the Office Action dated March 17, 2008.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 5 of this paper.